

TOLERANCES: .XX ± .01 .XXX ±

ANGULAR ± 0.1°

N/A 4

4. ALL MACHINING FLUIDS MUST BE FULLY SYNTHETIC, FULLY WATER SOLUBLE

N/A µinch

3. DO NOT SCALE FROM DRAWING.

AND FREE OF SULFUR, SILICONE, AND CHLORINE.

ADVANCED LIGO AOS

EXT ASSY

D1001517

SUB-SYSTEM

 DESIGNER
 A.Cole
 7/26/2010
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